

INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Not for submission under 37 CFR 1.99)	Application Number		10791334
	Filing Date		2004-03-01
	First Named Inventor	Gi Youl Kim	
	Art Unit	1792	
	Examiner Name	David P. Turocy	
	Attorney Docket Number	40004551-0025-002	

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	4	5879459		1999-03-09	Gadgil, Prasad N. et al.	
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	8	6503330		2003-01-07	Sneh, Ofer et al.	

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9	6270572		2001-08-07	Kim, Yeong-kwan et al.	
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3	J.W. ELAM et al., "Viscous Flow Reactor with Quartz Crystal Microbalance for Thin Film Growth by Atomic Layer Deposition", Rev. Sci. Instrum., 73, pp. 2981-2987 (2002)	<input type="checkbox"/>
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